# Underfill Training Report

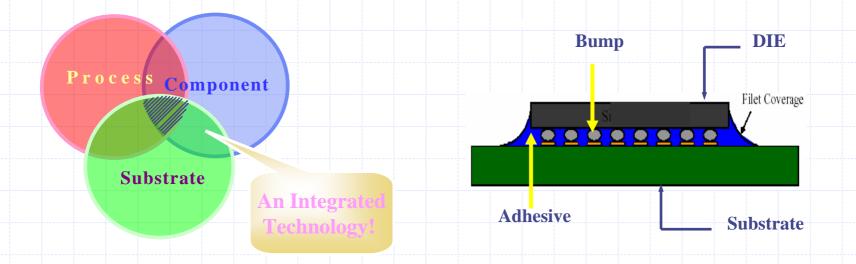
## Content

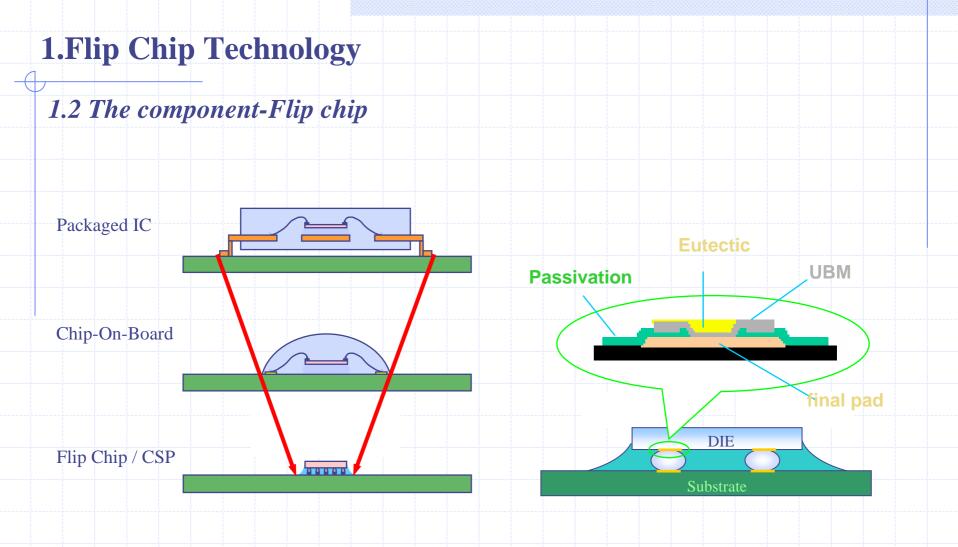
- Flip Chip Technology
- Underfill Process
- Underfill Machine
- Underfill Epoxy
- Underfill Failure Mode Analysis
- Applied Component and Foreground of Underfill

1.1 What is flip chip

It is a chip connection technology which interconnects an IC chip to its next level

of packaging in such manner that IC's active side faces to substrate.

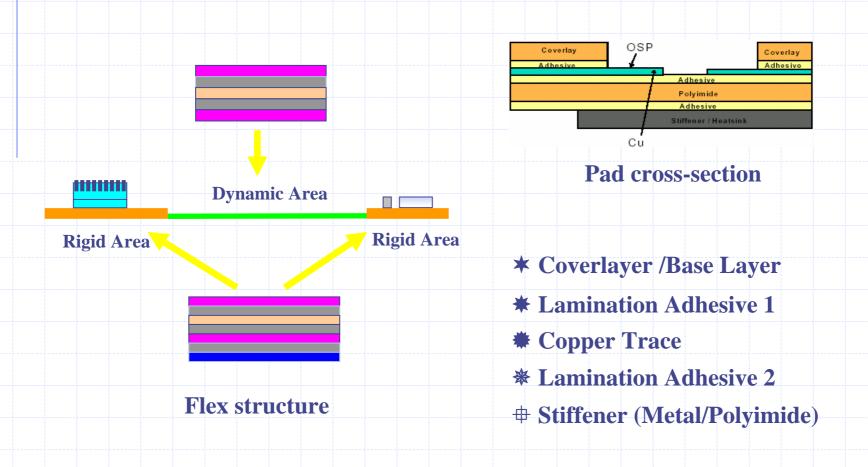


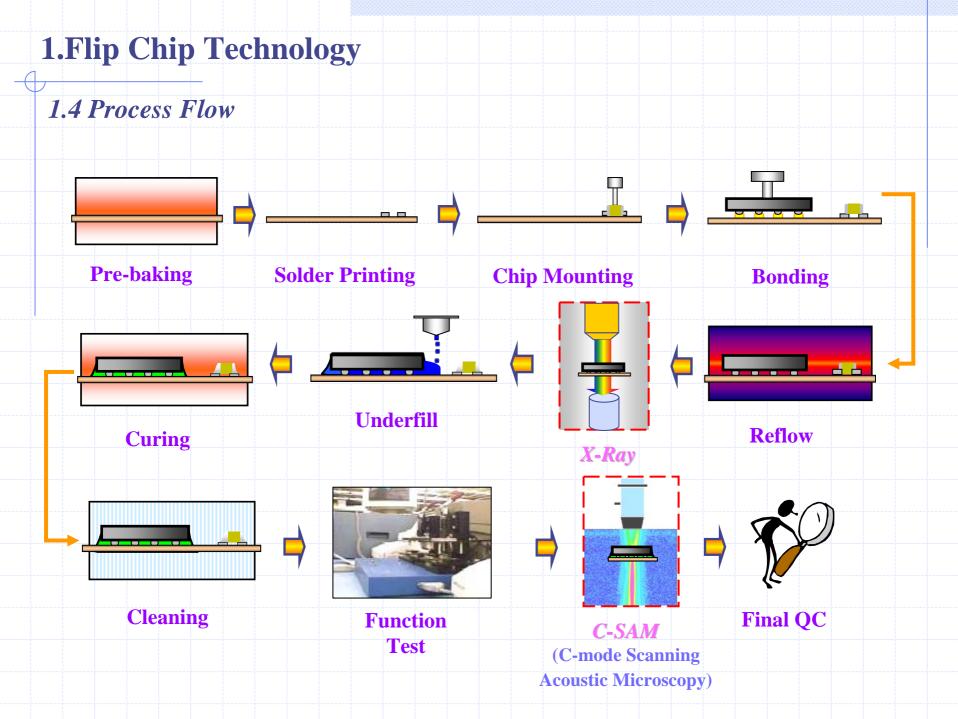


Shrinking electronic devices

Flip Chip bump configuration

### 1.3 Flex lamination layer(Cross section)





1.5 Why Underfill ?

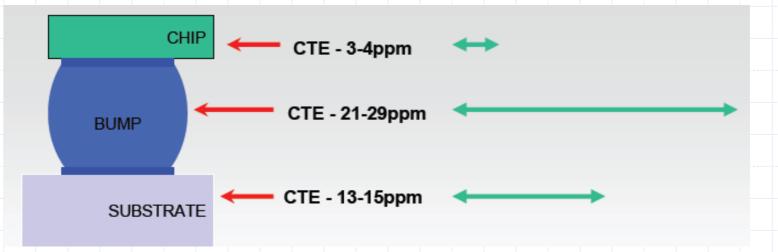
Underfill is required to encapsulate under the die to neutralize the effects of

CTE mismatch.

### Significance:

- Reduce stress due to thermal expansion
- Increase lifetime of connections
- Protect connections mechanically
- Reduce chance of contamination

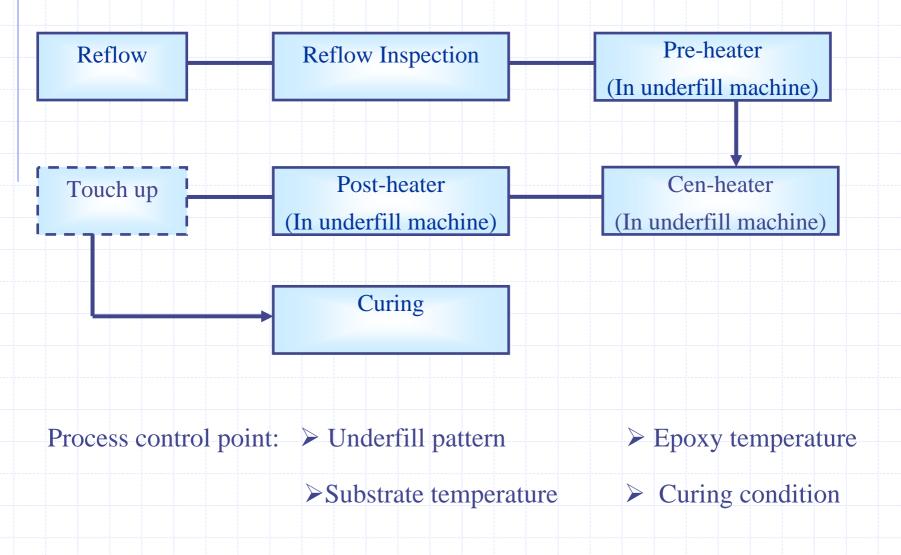
1.5 Why Underfill ?



CTE mismatch of varies components in Flip Chip package will cause high stress at the interconnection.

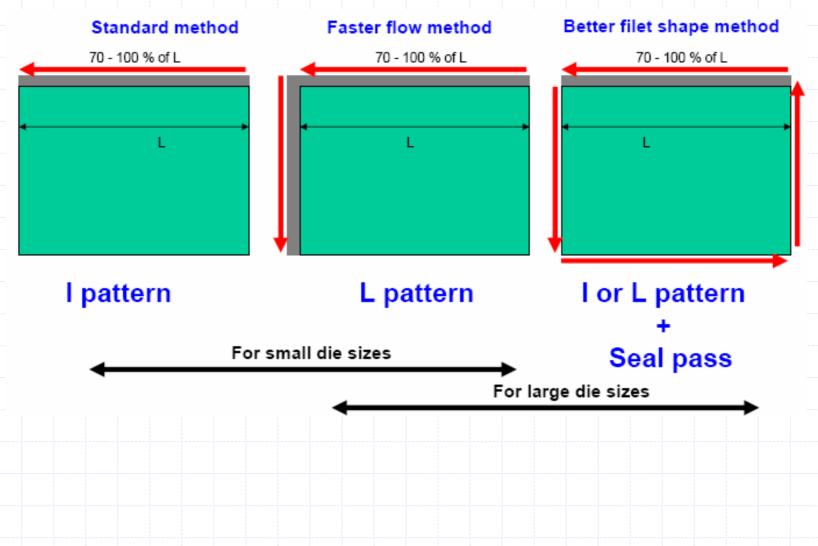
Underfill reduce Stress by distributing such stress over the entire chip area so the stress will not concentrated at the interconnections.

2.1 Relative process flow of underfill



2.2 Control point in underfill process

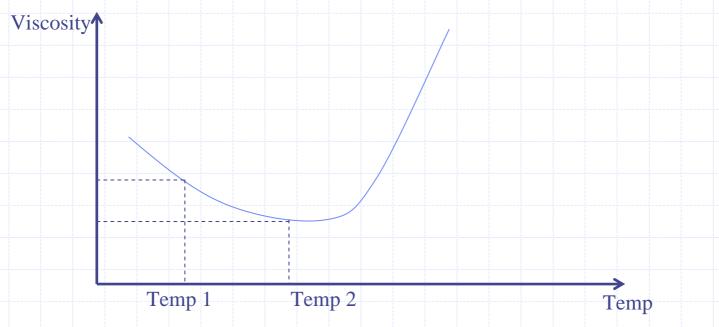
> Underfill pattern selection





Epoxy temperature when dispensing

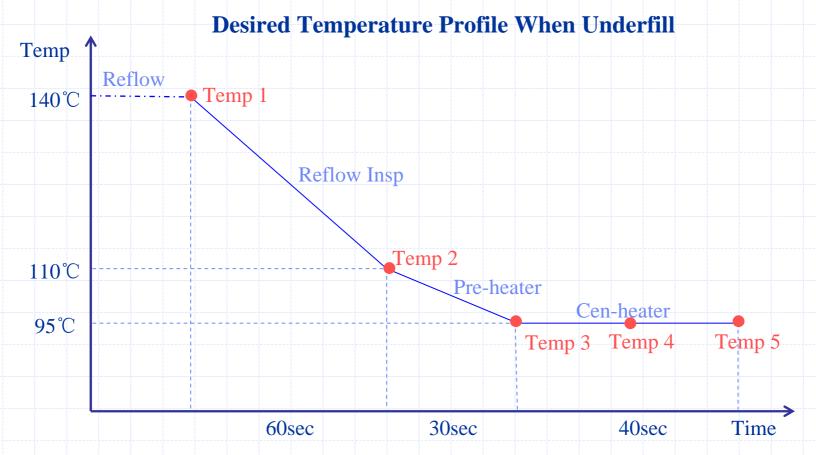
**Epoxy's viscosity profile** 



We select low viscosity temperature to insure epoxy can be dispensed out fluently and flow fast.

2.2 Control point in underfill process

> Substrate temperature when underfill



Dispensing temperature control is let the temperature stable when the pallet in Cenheater(Temp 3 to Temp 5).

2.2 Control point in underfill process

Curing condition

### Namics U8437-2 epoxy

Time of reaction rate X% at each temperature (min.)

<b>Reaction rate</b> (%)	Temperature( <sup>o</sup> C)			
	120	150	170	200
5%	1.1	0.1	0.0	0.0
50%	14.5	1.1	0.2	0.0
90%	18.1	3.6	0.8	0.1
99%	96.1	7.2	1.6	0.2
99.9%	144.2	10.8	2.3	0.3
99.99%	192.2	14.4	3.1	0.4
99.999%	240.3	18.0	3.9	0.5

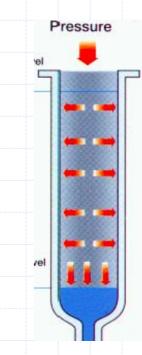
Insure the reaction rate surpass 99.99% is our control specification.

### 2.3 Process control in different underfill epoxy

Enosy	Item			
Epoxy -	Ероху Тетр	Substrate Temp	Curing Condition	
Namics U8433L	55~65C	95 <u>+</u> 5C	65C/15mins+150C/60mins	
Namics U8437-2	50~60C	85 <u>+</u> 10C	150C/60mins	
Hysol FP4530	55~65C	85 <u>+</u> 10C	165C/15mins	
Hysol FP4549	/	85 <u>+</u> 10C	165C/30mins	
Emerson E-1159	30C	50 <u>+</u> 10C	120C/30mins or 130/15mins	

3.1 Develop history of dispense valve → Air pressure time control





Now we use this for manual underfill

Ideal for use in low cost assembly areas

Very little maintenance Low cost Dispensed volume changes depending on the fill level of the syringe



DV-8K

•Easy to Clean

•Used for small dots dispensing of silver / solder paste and encapsulants

•Accuracy 3 to 5 % typical in the 10 to 100mg range

3.1 Develop history of dispense valve





3.1 Develop history of dispense valve

Dispense Jets



Dispenses adhesive material from a distance of 0.5 mm to 3 mm

Eliminates movement on the Z-axis between dots

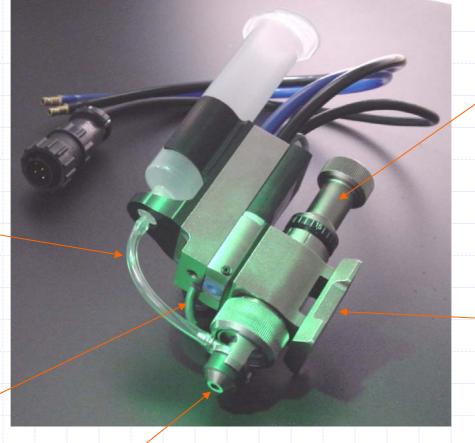
Jet dispenser cycles every 10 ms ( 360,000 cycle/h )



### 3.2 DJ-9K instruction

Material Feed Tube

Integrated Temperature Control

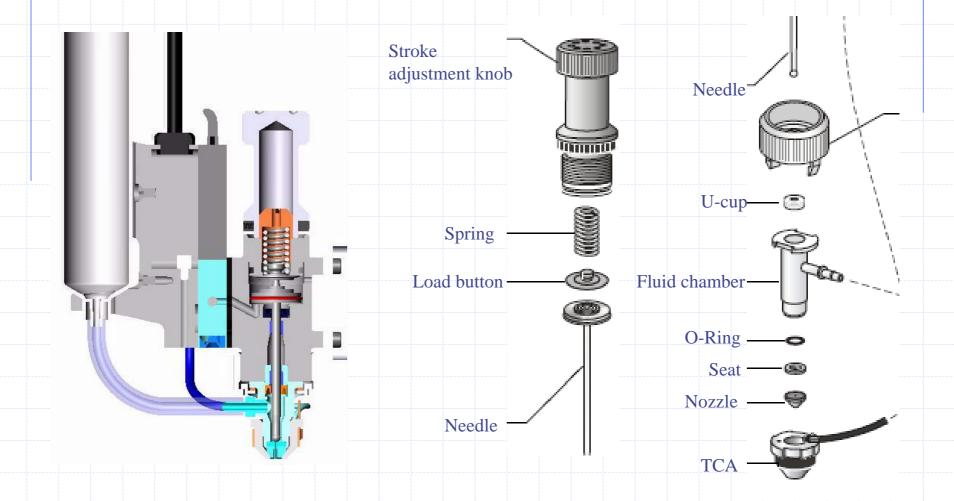


Piston Stroke Adjust

> Standard Dove Tail Adapter

Nozzle/Seat Assembly

### 3.2 DJ-9K instruction



### 3.2 DJ-9K instruction

### **Parameter setting on Toshiba FPCA**

- a. Seat:15mil
- b. Nozzle:6mil
- b. Stroke length:15unit
- c. Valve1 fluid air digital gauge: 15psi
- d. Valve on/off time: 4/4msec
- e. Needle heater temperature: 60C
- f. Substrate temperature: 90~100(setting:135)

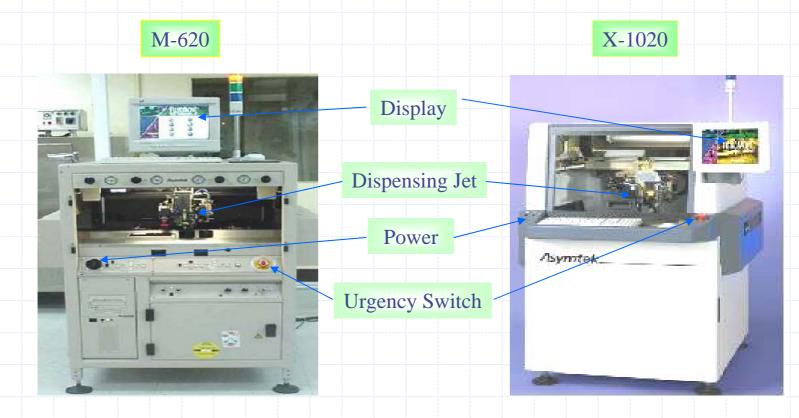
'Nozzle

**Dispense** Gap

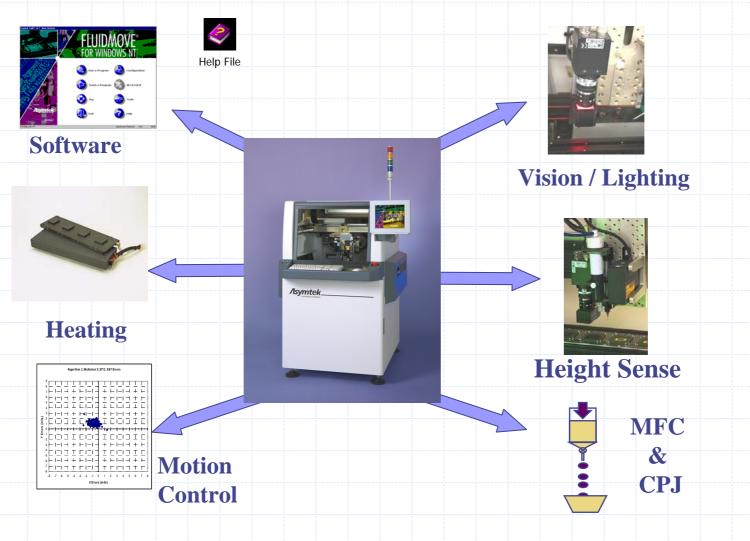
**Dispense** Distance

- h. Dispensing gap: 55~75mil
- i. Dispensing distance: 8~10mil

3.3 Structure of Asymtek underfill machine: M-620 and X-1020



### 3.4 X-1020 machine



- 3.4 X-1020 machine
  - How to edit a program
  - 1. Teach fiducial mark in workpiece to establish all sample's location (Two circular
    - metal point on pallet);
  - 2.Create pattern and teach fiducial mark on samples;
  - 3.Edit weight control line in pattern, this will establish underfill pattern, epoxy
    - volume, dispensing gap, dispensing distance and other parameter;
  - 4.Edit how the program running and teach each sample's location.

### 3.4 X-1020 machine

- How to save a program
- For optimal Production, a Program should contain three elements:
- 1.A Program File (dispensing commands, process commands, etc.)
- 2.A Fluid File (contains all relative parameters like dispense gap, dispense speed to each dot.)
- 3.A Vision File (saved automatically when teaching a program)
- 4.A Recipe File (above three elements, when saved and assembled, are

collectively called a Recipe.)

### 3.4 X-1020 machine

### FKV 2A0-U-9K-M-H-01 Program

Asymtek FmNT v4.8 - Programming Window	, 
<u>F</u> ile <u>E</u> dit <u>P</u> rogram <u>S</u> etup <u>R</u> un <u>V</u> iew <u>H</u> elp	
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Program: fkv2a0 gr01-u-9k-m-h-01.fmw Fluid1: FKV231 Fluid2: Pattern Name: Workpiece	•
1 FIND SUBSTRATE HEIGHT: [6.539, 4.169] line2 2 LOOP PASS: FROM 1 TO 4 Workpiece	-
3 DO MULTIPASS: line2 AT (9.297, 3.411) 4 DO MULTIPASS: line2 AT (7.641, 3.430) 5 DO MULTIPASS: line 2 AT (7.641, 3.450)	e\$
5 DO MULTIPASS: line2 AT (5.990, 3.450)   6 DO MULTIPASS: line2 AT (4.334, 3.470)   7 DO MULTIPASS: line2 AT (2.678, 3.486)	
8 DO MULTIPASS: line2 AT (1.023, 3.509) 9 DO MULTIPASS: line1 AT (-0.029, 3.418)	<b>\</b>
10 DO MULTIPASS: line1 AT (1.624, 3.402) 11 DO MULTIPASS: line1 AT (3.280, 3.381)	
12 DO MULTIPASS: line1 AT (4.938, 3.358) 13 DO MULTIPASS: line1 AT (6.588, 3.343)	*
14 DO MULTIPASS: line1 AT (8.246, 3.323) 15 NEXT LOOP: 16 PURGE: AT VALVE 1 PURGE LOC FOR 0.000 secs, VALVE 1	
17 END:	<b>N</b>
	Ö
For Help, press F1 Jog Device: Dispenser	inch

### 3.4 X-1020 machine

### FKV 2A0-U-9K-M-H-01 Program

Asymtek FmNT v4.8 - Programming Window					)
<u>F</u> ile <u>E</u> dit <u>P</u> rogram <u>S</u> etup <u>R</u> un <u>V</u> iew <u>H</u> elp					
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Program: fkv2a0 gr01-u-9k-m-h-01.fmw	Fluid1: FKV231	Fluid2:	Pattern	Name: line1	•
1 START PASS: FOR PASS 1					:/
2 WEIGHT CONTROL: 0.800, 1, 3 RESET MULTIPASS TIMER:					
4 END PASS:					<b>ल्जै</b>
5 START PASS: FOR PASS 2					
6 WEIGHT CONTROL: 0.640, 1, 7 END PASS:					
8 START PASS: FOR PASS 3					<b>S</b>
9 AWAIT MULTIPASS TIMER: 11 s 10 WEIGHT CONTROL: 0.300, 3,		r underfill			*
11 WEIGHT CONTROL: 0.360, 3,					
12 WEIGHT CONTROL: 0.300, 3,					<b>₽</b>
13 WEIGHT CONTROL: 0.360, 3, 14 END PASS:					
15 START PASS: FOR PASS 4					
16 END PASS:					sta.
17 END:					
					Ó
I For Help, press F1			Jo	g Device: Dispenser	inch

### 4.1 Epoxy datasheet (Namics U8437-2)

ITEM	UNIT	U8437-2
Filler content	wt%	55
Density		1.6
Colour		Black
Viscosity	Pa.s	40
Gel time(150C)	sec	40
Tg(TMA)	С	137
C.T.E(TMA) <tg< th=""><td></td><td>32</td></tg<>		32
>Tg	ppm/C	100
Bending modulus	Gpa	8.0
Bending strength	Mpa	130
Young's modulus	Gpa	7.0
Poisson ratio		0.33
Volume resistivity Initial	. 1	>1.0X1015
(500V) after PCT	ohm.cm	>1.0X1013
Moisture obsorption (after PCT)	wt%	1.4
Dielectric constant (1MHz)	-	3.5
Dielectric loss tangent (1MHz)		0.007 (0.7%)
Thermal conductivity	W/m.K	0.67
Purity (after PCT) Cl		2
Na	ppm	<1.0
K		<1.0
Alpha ray emision	cont/cm2.hr	<.001
PCT: 121C 2atm 20hours		

#### HOW TO USE

Standard dispensin	g condition
Needle	:18-23G
Temperature	:
Curing condition	:150Cx20min(Standard)
	:165Cx60min(High reliability temperature reflow)
Storage condition	:Below -20C
For a 10CC syring	e, over 1 hours is needed for the syringe to return to
room temperature	

#### **POT-LIFE**

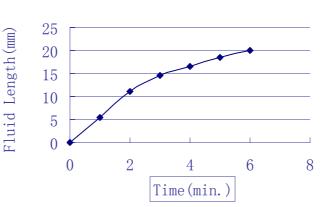
Double Viscosity at 25C:>72hours

#### ADHESION STRENGTH(2x2mm chip)

Shear strength:30kgf (Si Chip vs FR-4)

#### FLUIDITY TEST

Test conditionSubstrate:FR-4Chip:GlassGap:50umTemperature:70C



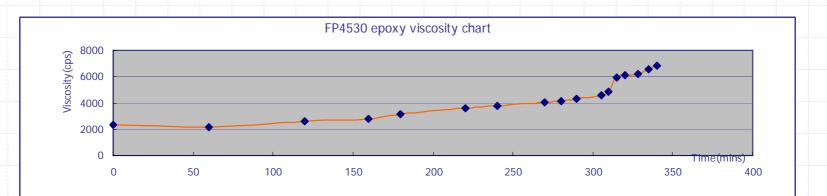
### 4.2 Property of process control

➤ Viscosity

Epoxy's viscosity affect the dispense method and machine parameter.

Double viscosity time(Epoxy's use life)

52# Spindle 50rpm at 30C



### 4.2 Epoxy property on process control

### ➢ Gel time

Epoxy's gel time is the time of epoxy from liquid to gel,underfill flow time should short than gel time.

➢ Moisture absorption

Moisture absorption is the ability of epoxy absorb moisture, low moisture absorption is good because more moisture in epoxy can cause epoxy can't

be cured completely.

### Curing schedule

Curing is made epoxy's molecular structure from chain to net,after this,epoxy become harden and firmed

### 4.2 Epoxy property on function

➢ Filler content

Affect epoxy's CTE, viscosity and bending strength

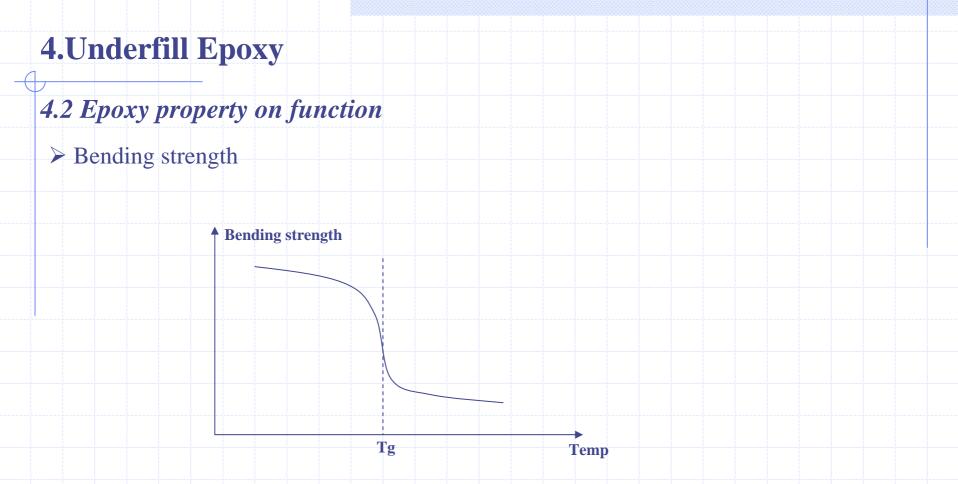
## ≻ Tg

Epoxy's glass transition temperature, high Tg avoid high temperature cause defect because after the epoxy changed into glass state, its molecular distance become big, it will cause CTE changed acutely and the epoxy become breakable.

### ≻ C.T.E.

Underfill epoxy is filled to reduce the C.T.E mismatch of chip and FPC, so the

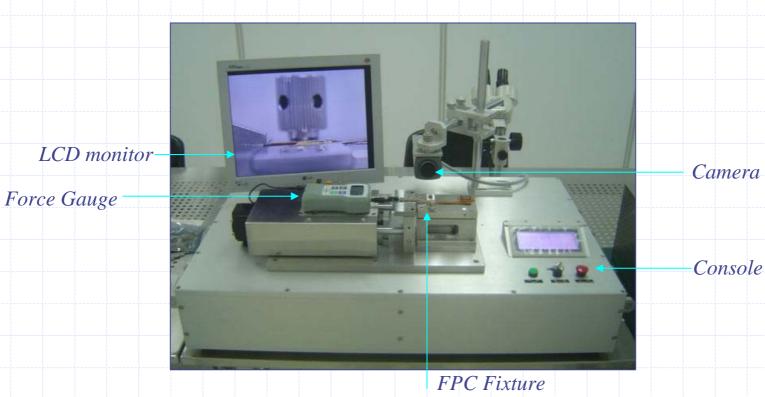
epoxy's CTE should near to chip and substrate's C.T.E.



Bending strength is the combine intensity between chip and FPC, it changed acutely when the temperature achieved to epoxy's Tg point.

### 4.2 Epoxy property on function

- Bending strength
  - Shear tester is used to test bending strength, shear knife go ahead with a
  - constant speed, if the epoxy was separate from FPC, the shear knife will stop and
  - a value will be showed on force gauge.



### 4.2 Epoxy property on function

- Thermal conductivity
  - Thermal conductivity is epoxy's capability to transfer heat, to the hard disk driver,
  - high thermal conductivity epoxy is acceptable.
- Volume resistivity
  - A concept in electrostatic, it shows material's electric conduct capability.

### Dielectric constant

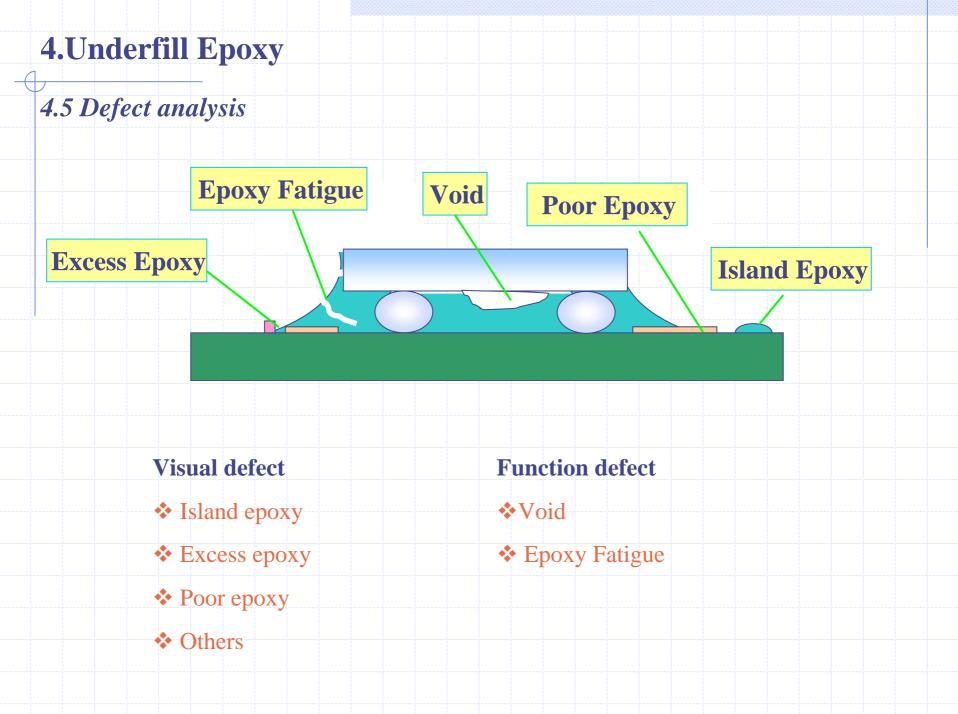
A coefficient which express material's insulating capability. To underfill epoxy, the high dielectric constant value, the better to use.

4.4 Ideal epoxy in underfill process

- High Tg/Low CTE/Low Modulus
- Low stress, Improve thermal shock, temp cycle
- + Good adhesion to all different surfaces
- High bonding strength
- + High Moisture Resistance
- + Fast flow
- Productivity
- + Fast cure
- Productivity

4.4 Ideal epoxy in underfill process

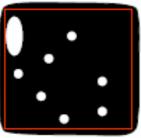
- + Low Shrinkage
- Low warpage
- + Low pot life
- **Stable in process**
- + No Void
- Dispensability
- + No filler separation
- **Uniform flow**
- + No toxicity



## 4.5 Defect analysis

≻ Void

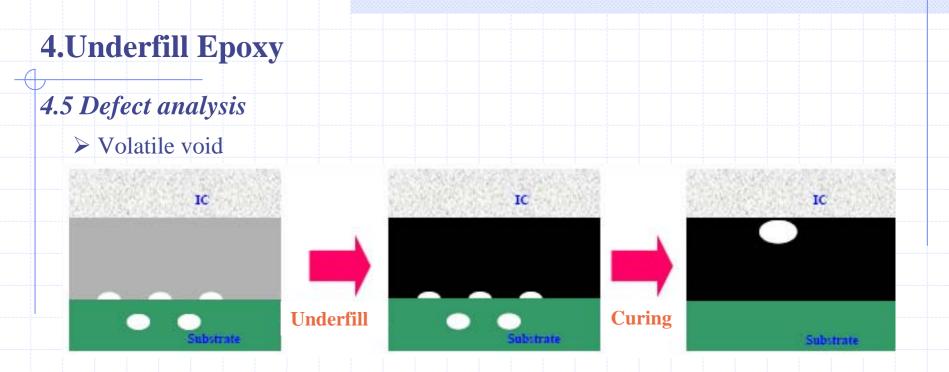
### Volatile void



### **Capture void**



- General cause&solution in process
  - ✓ Substrate temperature is not matched for underfill
  - ---- >> Refer to epoxy's datasheet and select proper temperature
  - ✓ Dispense pattern is not suitable for die shape
  - ---- >> Optimize underfill pattern
  - ✓ Dispense volume is not enough
  - ---- >> Dispensing with sufficient epoxy volume
  - ✓ Viscosity of underfill epoxy is high
  - ---- >> Use fresh underfill epoxy

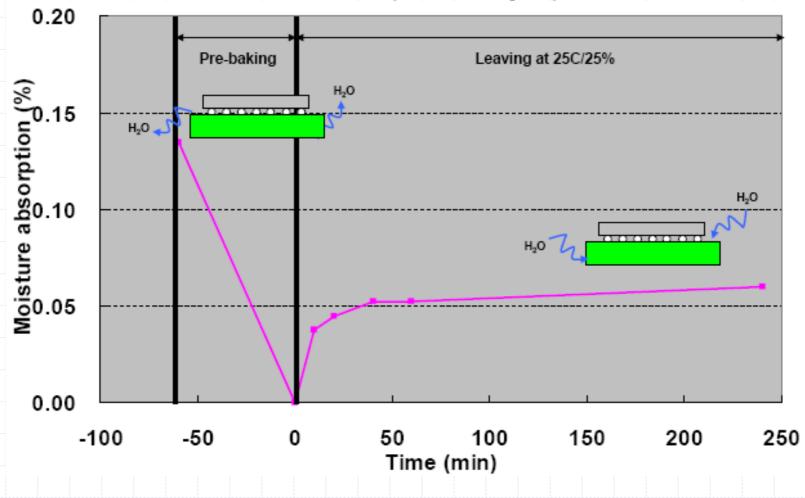


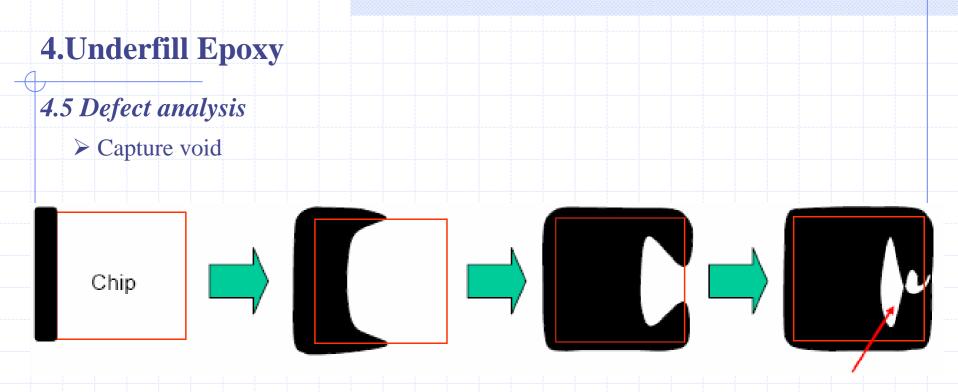
- Cause & solution
  - ✓ Absorb moisture of FPC
  - -- >> Dispensing duly after reflow
  - $\checkmark$  Poor wetting parts on substrate by flux residue exists
  - -- >> Reduce flux residue

## 4.5 Defect analysis

➤ Volatile void

### Moisture absorption changed profile





>>> Capture void

The flow speed > The penetrate speed

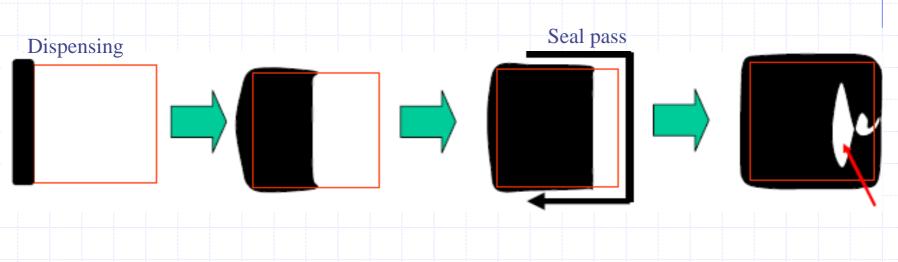
### Cause & solution

- ✓ Dispense pattern is not suitable for bump layout
- -- >> Select proper dispense pattern
- ✓ Die size is too big
- -- >> Optimize dispense method and select proper epoxy

➤ Capture void

4.5 Defect analysis

Underfill time too short in seal pass



- Cause & solution
  - ✓ Underfill time too short
  - -- >> Waiting for epoxy penetrate the whole chip then do seal pass

### 4.5 Relative test

C-SAM (SAM=Scaning acoustic microscopy)

C-SAM is a test method which use ultrasonic scan to establish solder layer, underfill layer is integrated or not.

Reflection of the ultrasonic beam at interfaces with impedance mismatch,,f.e. surface,

back wall, defects, layer interfaces...

**Cross section** 

Transverse section test, skive the sample to a surface (to void layer or filler delamination

layer and so on) and will get a view at the layer you want.

### **6.Flip Chip Applied Component**

### Hard Disk Driver



### 3mmX3mm

### Microprocessor



25mmX25mm (Biggest)

Memory

